



AMENDMENT UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
GROUP 1751  
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q79289

Masayuki TAKASHIMA, et al.

Appln. No.: 10/750,971

Group Art Unit: 1751

Confirmation No.: 1869

Examiner: Brian P. Mruk

Filed: January 5, 2004

For: CLEANING SOLUTION FOR SEMICONDUCTOR SUBSTRATE

AMENDMENT UNDER 37 C.F.R. § 1.116

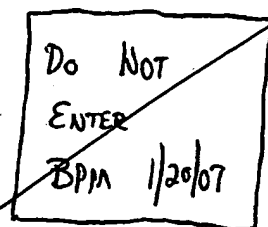
MAIL STOP AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 28, 2006, please amend the above-identified application as follows on the accompanying pages. A petition for extension of time is submitted herewith, extending the due date for response to December 28, 2006.

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Entered  
w/ RCE  
2.13.07

JML  
2.26.07